

In re application of : **Confirmation No. 7745**

Shoriki NARITA et al. : Docket No. 2003-1226

Serial No. 10/651,103 : Group Art Unit 2825

Filed August 29, 2003 : Examiner Igwe U. Anya

BUMP FORMING APPARATUS FOR CHARGE : **Mail Stop: AMENDMENT**  
APPEARANCE SEMICONDUCTOR SUBSTRATE,  
CHARGE REMOVAL METHOD FOR CHARGE  
APPEARANCE SEMICONDUCTOR SUBSTRATE,  
CHARGE REMOVING UNIT FOR CHARGE  
APPEARANCE SEMICONDUCTOR SUBSTRATE,  
AND CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE

**PETITION FOR ONE-MONTH EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of  
July 27, 2004.

**The fee of \$110.00 is**

**(X) submitted herewith.**

( ) to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

( ) Small entity status of this application is established by a Small Entity Status Assertion which

( ) is enclosed.

( ) has been previously submitted.

11/30/2004 FHETEKI1 00000133 10651103

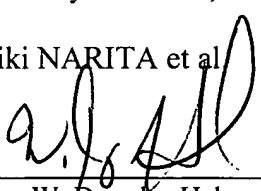
01 FC:1251

110.00 OP

Respectfully submitted,

Shoriki NARITA et al

By

  
W. Douglas Hahm

Registration No.44,142

Attorney for Applicants

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November 29, 2004

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975